

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

EXPRESS MAIL NO. EV327880615US

Appl No.	: N/A	Confirmation No.
Applicant	: Naoya Takeuchi	
Filed	: February 17, 2004	
Title	: PATTERN INSPECTION METHOD AND APPARATUS	
TC/A.U.	: N/A	
Examiner	: N/A	

Docket No. : 51971/DBP/A400

Customer No. : 23363

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Post Office Box 7068
Pasadena, CA 91109-7068
February 17, 2004

Commissioner:

Prior to examination, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.